Attorney Docket No. 021653-012200US

U.S. DEPARTMENT OF COMMERCE Form PTO-1595 (Rev. 03/05) United States Patent and Trademark Office OMB No. 0651-0027 (exp. 6/30/2005) RECORDATION FORM COVER SHEET PATENTS ONLY To the Director of the U.S. Patent and Trademark Office: Please record the attached documents or the new address(es) below. 2. Name and address of receiving party(ies) 1. Name of conveying party(les) Semiconductor Manufacturing Tsing Chow Wang Name: International (Shanghai) Corporation Internal Address: Street Address: 18 Zhang Jiang Rd. Additional name(s) of conveying party(ies) attached? 🔝 Yes 🔀 No 3. Nature of conveyance/Execution Date(s): Execution Date(s) February 22, 2005 City: Pudong New Area Merger X Assignment State: Shanghai Change of Name Security Agreement Joint Research Agreement Zip: 201203 Country: China Government Interest Assignment Executive Order 9424, Confirmatory License Additional name(s) & address(es) attached? 🔲 Yes 🔀 No Other This document is being filed together with a new application. 4. Application or patent number(s): B. Patent No.(s) A. Patent Application No.(s) 11/176,871 Tyes ⊠No Additional numbers attached? 5. Name and address to whom correspondence 6. Total number of applications and patents involved: concerning document should be mailed: 7. Total fee (37 CFR 1.21(h) & 3.41) \$ 40.00 Name: Kent J. Tobin Authorized to be charged by credit card Internal Address: |X| Authorized to be charged to deposit account TOWNSEND AND TOWNSEND AND CREW LLP **Enclosed** Street Address: Two Embarcadero Center, None required (government interest not affecting title) Eighth Floor 8. Payment Information City: San Francisco a. Credit Card Last 4 numbers, California Zip: 94111-3834 State: **Expiration Date** Phone Number: (415) 576-0200 b. Deposit Account Number 20-1430 Fax Number: (415) 576-0300 Authorized User Name Townsend and Email Address: kjtobin@townsend.com Townsend and Crew LLP 9/26/45 9. Signature: Signature Kent J. Tobin Total number of pages including cover

Documents to be recorded (including cover sheet) should be faxed to (703) 308-5995, or mailed to:
Mail Stop Assignment Recordation Services, Director of the USPTO, P.O.Box 1450, Alexandria, MAC 2012 No.

Atty. Reg. No. 39,496

Name of Person Signing

sheet, attachments, and documents:

Attorney Docket No.: 021653-012200US

Client Reference No.: I-04-264

ASSIGNMENT OF PATENT APPLICATION

SOLE

WHEREAS, Tsing Chow Wang of 18 Zhang Jiang Rd., Pudong New Arca, Shanghai, 201203, China, hereinafter referred to as "Assignor," is the inventor of the invention described and set forth in the belowidentified application for United States Letters Patent:

Title of Invention:

METHOD OF FORMING LOW STRESS MULTI-LAYER

METALLURGICAL STRUCTURES AND HIGH RELIABLE LEAD FREE SOLDER TERMINATION

ELECTRODES

Date(s) of execution of Declaration:

Filing Date:

July 6, 2005

Application No.: 11/176,871

: and

WHEREAS, Semiconductor Manufacturing International (Shanghai) Corporation, a corporation of Peoples' Republic of China, located at 18 Zhang Jiang Rd., Pudong New Area, Shanghai, 201203, China, hereinafter referred to as "ASSIGNEE," is desirous of acquiring an interest in the invention and application and in any U.S. Letters Patent and Registrations which may be granted on the same;

For good and valuable consideration, receipt of which is hereby acknowledged by Assignor, Assignor has assigned, and by these presents does assign to Assignee all right, title and interest in and to the invention and application and to all foreign counterparts (including patent, utility model and industrial designs), and in and to any Letters Patent and Registrations which may hereafter be granted on any patent application claiming priority from the same in the United States and all countries throughout the world, and to claim the priority from the application as provided by the Paris Convention. The right, title and interest is to be held and enjoyed by Assignee and Assignee's successors and assigns as fully and exclusively as it would have been held and enjoyed by Assignor had this Assignment not been made, for the full term of any Letters Patent and Registrations which may be granted thereon, or of any division, renewal, continuation in whole or in part, substitution, conversion, reissue, prolongation or extension thereof.

Assignor further agrees that Assignor will, without charge to Assignee, but at Assignee's expense, (a) cooperate with Assignee in the prosecution of U.S. Patent applications and foreign counterparts on the invention and any improvements, (b) execute, verify, acknowledge and deliver all such further papers, including applications and instruments of transfer, and (c) perform such other acts as Assignee lawfully may request to obtain or maintain Letters Patent and Registrations for the invention and improvements in any and all countries, and to vest title thereto in Assignee, or Assignee's successors and assigns.

Assignor hereby authorizes and requests Townsend and Townsend and Crew LLP, Two Embarcadero Center, Eighth Floor, San Francisco, CA 94111-3834, to insert herein above the application number and filing date of said application when known.

IN TESTIMONY WHEREOF, Assignor has signed his/her name on the date indicated.

RECORDED: 09/26/2005

Tsing Chow Wang

60413471 v1

PATENT REEL: 016841 FRAME: 0524